Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	14	brittle and protective and micromirror	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/02/06 10:06
L2	5975	brittle and protective and substrate	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/02/06 10:06
L3	30	2 and micromechanical	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/02/06 10:07

	Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
→ eva	L1 ce	14	brittle and protective and micromirror	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/02/06 10:06
	L2	5975	brittle and protective and substrate	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/02/06 10:06
	L3	30	2 and micromechanical	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/02/06 10:17
	L4	248	2 and microelectronic	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	OFF	2006/02/06 10:17